Electronic Filing System (EFS) Data
Electronic Patent Application Submission
USPTO Use Only

EFS ID:	26930
Application ID:	10023259
Title of Invention:	Microneedle devices and production thereof.
First Named Inventor:	Jung-Hwan Park
Domestic/Foreign Application:	Domestic Application
Filing Date:	2001-12-14
Effective Receipt Date:	2003-05-13
Submission Type:	Information Disclosure Statement
Filing Type:	
Confirmation number:	6122
Attorney Docket Number:	BVTP-P01-590

Total Fees Authorized:

Digital Certificate Holder: **cn=Agnes S. Lee, ou=Registered Attorneys, ou=Patent and Trademark Office, ou=Department of Commerce, o=U.S. Government, c=US**
Certificate Message Digest: **OKN6Q7pifahH2N0s/EtW7A==**

RECEIVED
MAY 2 3 2003
TECHNOLOGY CENTER R3700

TRANSMITTAL FORM

Electronic Version 1.0.3

Stylesheet Version: 1.0

Submission Type: **Information Disclosure Statement**

Application Number: **10023259**

Attorney Docket Number: **BVTP-P01-590**

Microneedle devices and production thereof.

First Named Inventor: **Jung-Hwan Park**

SUBMITTED BY

Name: **Agnes S. Lee**

Registration Number: **46862**

Electronic Signature Mark: **ASL**   Date Signed: **20030513**

I certify that the use of this system is for OFFICIAL correspondence between patent applicants or their representatives and the USPTO. Fraudulent or other use besides the filing of official correspondence by authorized parties is strictly prohibited, and subject to a fine and/or imprisonment under applicable law.

I, the undersigned, certify that I have viewed a display of document(s) being electronically submitted to the United States Patent and Trademark Office, using either the USPTO provided style sheet or software, and that this is the document(s) I intend for initiation or further prosecution of a patent application noted in the submission. This document(s) will become part of the official electronic record at the USPTO.

Attached Files:

us-information-disclosure-statement   BVTP-P01-590p3ids.xml